

Application/Control No.	Applicant(s)/Patent under Reexamination	-
10/584,089	ISOBE, SHINICHIRO	
Examiner	Art Unit	
 Jezia Rilev	1637	

	SEAR	CHED	
Class	Subclass	Date	Examiner
435	6,91.1	12/15/2008	JR
536	23.1,24.3	12/15/2008	JR
536	26.6	12/15/2008	JR

INT	ERFERENC	E SEARCH	SEARCHED		
Class	Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH)	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
·	DATE	EXMR			